



Image

Receipt

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q61067

Markku RŽSŽNEN, et al.

Appln. No.: 09/647,458

Group Art Unit: 2851

Confirmation No.: 7640

Examiner: Alan A. Mathews

Filed: September 29, 2000

For: METHOD AND APPARATUS FOR ANALYSIS OF GAS COMPOSITIONS

**SECOND REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT**

**ATTN:** Office of Initial Patent Examination

Filing Receipt Correction

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Again, we enclose a copy of the Official Filing Receipt for the above-identified application and request the following correction:

"This application is a 371 of PCT/FI99/00288 09/29/2000"

should be

--This application is a 371 of PCT/FI99/00288 **04/06/1999**--.

Verification for the requested correction is indicated on the original Declaration and Power of Attorney filed December 6, 2000, a copy of which is enclosed with a copy of the date-stamped mailroom receipt from December 6, 2000. Also enclosed is a copy of our first Request

SECOND REQUEST FOR CORRECTED  
OFFICIAL FILING RECEIPT  
U.S. Appln. No. 09/647,458

for Corrected Filing Receipt filed December 31, 2002, together with a copy of the date-stamped  
mailroom receipt dated December 31, 2002


Respectfully submitted,

SUGHRUE MION, PLLC  
Telephone: (202) 293-7060  
Facsimile: (202) 293-7860

WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

  
Susan Perng Pan  
Registration No. 41,239

Date: October 1, 2003



46

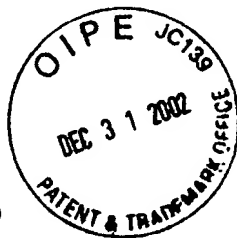
PLEASE DATE STAMP AND RETURN TO US - BOX 235X

In re Application of:

Markku RÄSÄNEN et al

Appln. No.: 09/647,458

Filed: September 29, 2000



Conf. No.: 7640

Group Art Unit: 2877

Examiner: Smith, Z.

For: **METHOD AND APPARATUS FOR ANALYSIS  
OF GAS COMPOSITIONS**

PAPER ENTITLED: (1) **REQUEST FOR CORRECTED  
OFFICIAL FILING RECEIPT**  
(accompanied by the Official  
Filing Receipt, a copy of the  
Declaration and Power of  
Attorney and date-stamped  
mailroom receipt).

**SUGHRUE MION, PLLC**  
2100 Pennsylvania Avenue, N.W.  
Washington, D.C. 20037-3213

DOCKET NO: **Q-61067**  
ATTORNEY: **GK/vf**

WASHINGTON OFFICE



**23373**

PATENT TRADEMARK OFFICE

Date: December 31, 2002



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Markku RÄSÄNEN et al

Conf. No.: 7640

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Group Art Unit: 2877

Filed: September 29, 2000

Examiner: Smith, Z.

For: METHOD AND APPARATUS FOR ANALYSIS  
OF GAS COMPOSITIONS

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Commissioner for Patents  
Office of Initial Patent Examination  
Customer Service Center  
Washington, D.C. 20231

Sir:

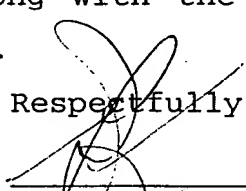
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Verification for the requested correction is indicated on  
the original Declaration and Power of Attorney filed  
December 6, 2000 (a copy of which, along with the date-stamped  
mailroom receipt therefor, is attached).

Respectfully submitted,

  
Gordon Kit

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WASHINGTON OFFICE



23373

PATENT TRADEMARK OFFICE

**FILED**

DEC 31 2002

Date: December 31, 2002



Commissioner for Patents  
Washington, DC 20231  
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/647,458	12/06/2000	2877	1215	Q-61067	2	30	3

CONFIRMATION NO. 7640

## REPLACEMENT FILING RECEIPT



\*OC00000009278048\*

Sughrue Mion Zinn  
Macpeak & Seas  
2100 Pennsylvania Avenue NW  
Washington, DC 20037-3213

Date Mailed: 12/20/2002

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

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Mika Petterson, Vantaa, FINLAND;

## Domestic Priority data as claimed by applicant

This application is a 371 of PCT/FI99/00288-09/29/2000

04/06/1999

## Foreign Applications

FINLAND 980781 04/03/1998

If Required, Foreign Filing License Granted: 12/20/2000

Projected Publication Date: None, application is not eligible for pre-grant publication

Non-Publication Request: No

Early Publication Request: No

\*\* SMALL ENTITY \*\*

## Title

Method and apparatus for analysis of gas compositions

**Preliminary Class**

356

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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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